20

5

## WHAT IS CLAIMED IS:

- A thin film formation apparatus comprising:
   a head portion having an ultrasonic oscillator; and
   a nozzle filled with an application liquid for forming an EL layer.
- A thin film formation apparatus comprising:
   a head portion having an ultrasonic oscillator; and
   a nozzle filled with an application liquid for forming an EL layer,
   wherein said nozzle has a heater.
- A thin film formation apparatus according to claim 2, wherein said nozzle has a large internal diameter portion and a small internal diameter portion, and said heater is formed in said small internal diameter portion.
- A thin film formation apparatus according to claim 2, wherein the small internal diameter portion of the nozzle has a contact element.
- A thin film formation apparatus according to claims 1 or 2, wherein said application liquid in said nozzle is pressurized by ultrasonic oscillations, and is pushed out from said nozzle.
  - 6. A method of manufacturing a self-light-emitting device, comprising the steps of: filling a nozzle with an application liquid for forming an EL layer; and applying said application liquid to a pixel column in accordance with applying

5

10

ultrasonic oscillations or heat.

7. A method of manufacturing a self-light-emitting device according to claim 6, wherein:

said nozzle has a large internal diameter portion and a small internal diameter portion;

said small internal diameter portion has a heater; and said heater applies heat to the application liquid filling the nozzle.

8. A method of manufacturing a self-light-emitting device, comprising the steps of: imparting ultrasonic oscillations to a nozzle of a head portion by using an ultrasonic oscillator; and

imparting ultrasonic oscillations to an application liquid filling said nozzle by using said ultrasonic oscillator.

- A method of manufacturing a self-light-emitting device according to claim 8, wherein a heater of said nozzle applies heat to said application liquid filling said nozzle.
- 10. A method of manufacturing a self-light-emitting device according to claims 6 or 20 8, wherein said application liquid is pushed out from said nozzle in accordance with pressurization, and is applied.
  - 11. A method of manufacturing a self-light-emitting device according to claims 6 or 8, wherein said application liquid is pushed out from said nozzle in accordance with: capillary

action; the weight of said application liquid; or pressure; and is applied.

- 12. A method of manufacturing a self-light-emitting device according to claims 6 or 8, wherein said application liquid filling said nozzle is applied in accordance with a contact
- element of said nozzle contacting a bank.